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IFW

Docket No.: 8733.517.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Seung-Kyu Choi et al.

Confirmation No.: 2898

Application No.: 10/028,304

Art Unit: 2826

Filed: December 28, 2001

Examiner: J. P. Mondt

For: THIN FILM TRANSISTOR SUBSTRATE AND  
FABRICATING METHOD THEREOF

Customer No.: 30827

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated December 31, 2003 (Paper No. 12212003),  
please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 3 of this paper.

**Remarks** begin on page 10 of this paper.